



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

NAGAHAMA et al

Atty. Ref.: 925-179

Serial No. 09/500,288

Group: 2814

Filed: February 8, 2000

Examiner: Louie

For: NITRIDE SEMICONDUCTOR DEVICE AND MANUFACTURING
METHOD

*19/EET (1 month)
Imat A.
P. Lee
11-13-01*

* * * * *

November 2, 2001

Assistant Commissioner for Patents
Washington, DC 20231

Sir:

AMENDMENT

Responsive to the Official Action dated July 2, 2001 (for which
petition is hereby made for a one month extension of time), please amend
the above-identified application as follows:

IN THE CLAIMS

Cancel claims 1 through 6.

Add the following new claims 9-16: